## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: O84448

Michel PUECH

Appln. No.: 10/516,457 Group Art Unit: 1792

Confirmation No.: 2874 Examiner: Jeffrie Robert LUND

Filed: December 3, 2004

For: HEATER LINER FOR A PLASMA ETCHING REACTOR, AND AN ETCHING

METHOD USING THE LINER

## NOTICE OF APPEAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated December 20, 2007.

The statutory fee of \$510.00 is being authorized via EFS filing. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

SUGHRUE MION, PLLC Telephone: (202) 293-7060 Facsimile: (202) 293-7860

WASHINGTON OFFICE
23373
CUSTOMER NUMBER

Date: May 20,2008

/DJCushing/ David J. Cushing Registration No. 28.703